

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|                  |   |                 |                      |
|------------------|---|-----------------|----------------------|
| Applicant(s)     | Brechm et al.   | Examiner:       | Zimmerman, Joshua D. |
| Serial No.:      | 10/564,506  | Group Art Unit: | 2854                 |
| Confirmation No: | 9411  | Docket:         | 1093-148 PCT/US      |
| Filed:           | January 12, 2006  | Dated:          | April 21, 2009       |
| For:             | METHOD FOR PRODUCING A HIGH<br>RESOLUTION SURFACE PATTERN |                 |                      |

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

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Anne Arlauskas

(Printed Name)

Signature: /anne arlauskas/

**RESPONSE TO RESTRICTION REQUIREMENT**

Sir:

In the Office Action mailed April 1, 2009, the Examiner has imposed a Restriction Requirement to one of the following inventions under the provisions of 35 U.S.C. § 121:

Group I, Claims 1-16, drawn to a process for producing a high-resolution surface pattern;

Group II, Claims 17-21, drawn to a multi-layer body; and

Group III, Claims 22-24, drawn to an apparatus for producing a high-resolution surface pattern on a substrate.

In response to the Restriction Requirement, Applicants elect the subject matter defined by Claims 1-16 (Group I) without traverse. Applicants reserve the right to pursue the non elected claims in one or more divisional applications.

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In view of the present election, it is believed that this application is in condition for further consideration and examination. If resolution of any remaining issues is required prior to examination of the application, it is respectfully requested that the Examiner contact Applicants' undersigned attorney at the telephone number provided below.

Respectfully submitted,

*/steven t zuschlag/*

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Steven T. Zuschlag  
Registration No: 43,309  
Attorney for Applicants

HOFFMANN & BARON, LLP  
6900 Jericho Turnpike, Suite 200  
Syosset, New York 11791  
United States of America  
(516) 822-3550  
STZ/aca

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